

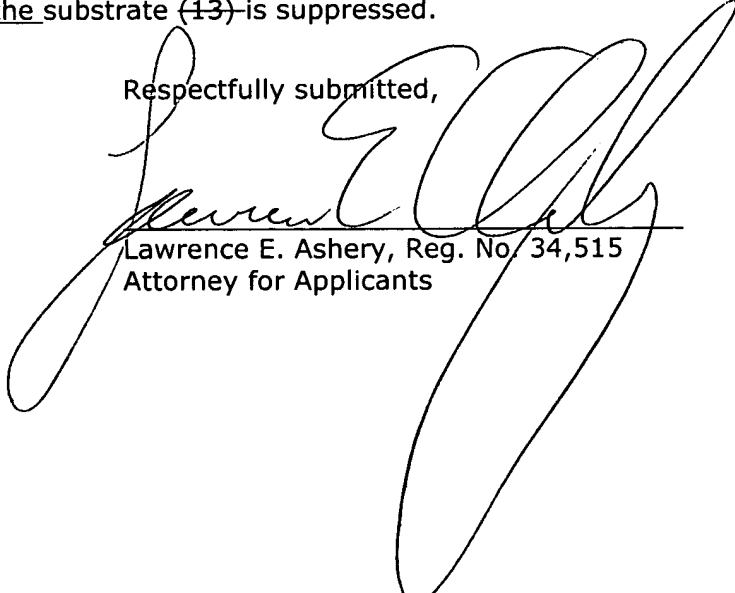
Amendment to the Abstract:

The Abstract has been amended. A revised Abstract is attached.

ABSTRACT

A method of manufacturing plasma display panels using a substrate holder (1) for deposition on a substrate (13) of the plasma display panel. The Substrate substrate holder (1) is configured with plural frames (2), and the substrate (13) of the plasma display panel is held by its periphery with at least one of these frames (2). A frame Frame (2) holding the substrate (13) has a protrusion (5) extending to a non-deposition face (13b) of the substrate held in such a way as to surround the substrate (13). Since the protrusion (5) acts as a blocking sheet, attachment of a deposition material passing through an opening (4) on the substrate holder (1) and reaching onto the non-deposition face (13b) of the substrate (13) is suppressed.

Respectfully submitted,


Lawrence E. Ashery, Reg. No. 34,515
Attorney for Applicants

LEA/fp

Attachments: Abstract

Dated: January 20, 2005

P.O. Box 980
Valley Forge, PA 19482-0980
(610) 407-0700

The Commissioner for Patents is hereby authorized to charge payment to Deposit Account No. **18-0350** of any fees associated with this communication.

EXPRESS MAIL: Mailing Label Number: EV 504 353 700 US
Date of Deposit: January 20, 2005

I hereby certify that this paper and fee are being deposited, under 37 C.F.R. § 1.10 and with sufficient postage, using the "Express Mail Post Office to Addressee" service of the United States Postal Service on the date indicated above and that the deposit is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


KATHLEEN LIBBY